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PATENT  
REV. DIL AMAT/5182/DISPLAY/INT/RKK

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**In re Application of:**  
**Shang, et al.**

**Serial No.: 10/024,985**

**Confirmation No.: 4811**

**Filed: December 18, 2001**

**For: Full Glass Substrate  
Deposition in Plasma  
Enhanced Chemical Vapor  
Deposition**

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**Dear Sir:**

**मा मा मा मा मा मा मा मा मा मा मा मा**

**Group Art Unit: 1763**

Examiner. Anna M. Crowell

**CERTIFICATE OF FACSIMILE  
TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number (703) 872-9305 to the attention of the named Examiner, on the date below.

12/13/04  
Date

**Signature**

## PETITION FOR ONE-MONTH EXTENSION OF TIME

Applicant respectfully petitions the Commissioner under 37 CFR 1.136(a) to grant a one-month extension of time to and including December 13, 2004, in which to file the Continuation Application (copy coversheet attached).

**This form is filed in duplicate. The Commissioner is authorized to charge the fee of \$120.00 and any additional fees which may be required for this submission to Deposit Account No. 20-0782/5162/KMT.**

**Respectfully submitted,**

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